

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/566,116 Confirmation No. 3700
Applicant : Akihisa Inoue et al.
371 Filed : January 24, 2006
Art Unit : 1734
Examiner : Weiping Zhu
Customer No. : 00270
Title : SPUTTERING TARGET AND METHOD FOR PRODUCTION THEREOF

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This is a Response submitted in reply to a non-final Office Action dated January 20, 2011. A Petition for a One Month Extension of Time to extend the deadline for response from April 20, 2011 to May 20, 2010 is filed herewith.

Remarks/Arguments begin on page 2 of this paper.